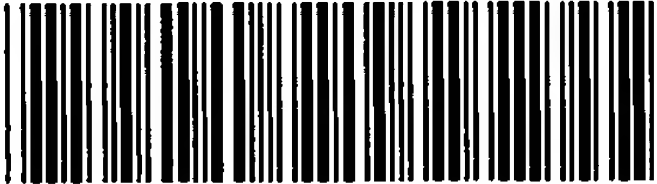


<div>Search Notes</div> <div></div>	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/679,771	HAN ET AL.	
	Examiner	Art Unit	
	Richard H. Kim	2871	

SEARCHED			
Class	Subclass	Date	Examiner

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
East Text Search (349/64,65)- jp,epo,uspat,pgpub-see search history printout	8/29/2007	RHK